

## TEM AND COMPUTING PROCEDURES IN CRYSTAL STUDIES

### I. CALIBRATION OF THE ELECTRON MICROSCOPE

by

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**Abstract:** *Tables and diagrams necessary for the calibration of the microscope are given. Based on these data, accurate calculations, either on the screen during the observation or on the positive prints afterwards, can be executed.*

#### 1. INTRODUCTION

The JEOL 120 CX electron microscope has a eucentric side entry goniometer stage with tilting facilities within the range of  $\pm 60^\circ$ . With such a stage the tilt axis can be adjusted so that the image of the specimen can be always tilted by an axis passing through a diameter of the screen.

It is well known that for each one of the functions of the microscope (SA DIF, SA MAG etc.) there are different rotations of the image, due to the different imaging procedure by the magnetic lenses and to their different excitation. Therefore, it is necessary for the operator to know the direction of the tilt axis on the screen for each function. Once this is known, the rotation relationship between different cases will be also known. This calibration enables the use of the instrumental coordinate system<sup>1</sup> and, therefore, a lot of tilting experiments can be easily carried out.

The results following will be given for both systems, the one which the operator uses and the other one for positive prints, because, in electron microscopy, people usually refer their results to positive prints, i.e. to photographs printed with emulsion down.

## 2. DEFINITIONS

a) Directions on the screen (for the operator).

The calibration was made in terms of the instrumental system in order to have the coordinates of a direction compatible with computing procedures, which usually are constructed for positive prints. This means that, if the direction of the real position of the mechanical tilt axis (MTA) is from South to North ( $\overrightarrow{SN}$ ), as in Fig. 1, then its image  $\overrightarrow{PQ}$  is characterized by a negative rotation angle  $-\varphi$  if the entrance point is lying in the eastern semicircle (as in Fig. 1) and by a positive one if the entrance point is in the western semicircle (zero angle at point N). The tilt angle  $\delta$ , which is readed on the goniometer stage, is taken as positive for counter-clockwise rotations and vice versa. When observing the screen, positive tilt values correspond to directions towards the left side of the direction  $\overrightarrow{PQ}$ . For example, if for the case of Fig. 1  $\delta$  was positive, the correct direction would be  $\overrightarrow{OA'}$  and not  $\overrightarrow{OA}$ . The angle  $POA'$  is characterized as  $+\alpha$  according to the system of coordinates proposed<sup>1</sup>, because it is on the left side of  $\overrightarrow{PQ}$ .

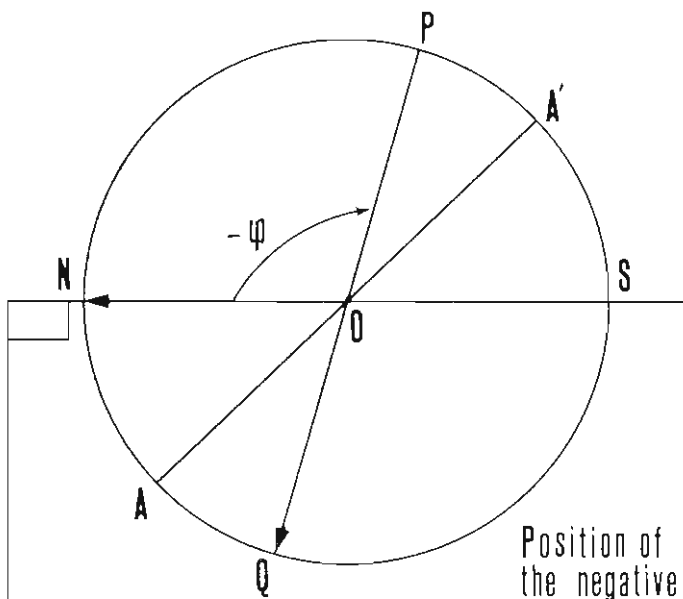


Fig. 1



for the operator and they are graphically presented in Fig. 3a while the corresponding graphs for positive prints are presented in Fig. 3b.

TABLE 1

*Rotation angles calculated for the different functions of the JEM 120 CX electron microscope  
(Accelerating Voltage 100 kV)*

SA DIF		SA MAG		MAG		MAG (contin.)	
Camera length	Angle $\varphi^{\circ}$	Magnif. ( $\times 10^{-3}$ )	Angle $\varphi^{\circ}$	Magnif. ( $\times 10^{-3}$ )	Angle $\varphi^{\circ}$	Magnif. ( $\times 10^{-3}$ )	Angle $\varphi^{\circ}$
32	-134,8	5.9	69	2,4	0	28	100
74	-111,4	8.9	86	2,9	-170	34	105
120	147,5	12	91	3,6	-157	46	115
190	152,3	17	-12,5	4,7	-135	56	130
390	170	23	-15	5,9	-120	83	9
580	-170	28	-13,5	8,9	-125	110	13
LOW	MAG	34	-12,5	12	-130	160	24
Magnif. ( $\times 10^{-3}$ )	Angle $\varphi^{\circ}$	46	-7	14	84,5	210	32
0.8	- 87.8	56	1	17	87	260	40
1.2	-63	83	8	23	92,5	400	63
		110	30	SCAN : Angle	$\varphi = -170,5$		

#### 4. COMPUTING PROCEDURE

A basic problem in electron microscopy is to orient the crystal within the instrumental coordinate system in order to be easy for the operator to find the crystal coordinates (Miller's indices) of any observed direction and also to find the instrumental coordinates of a desired crystallographic direction.

To solve this problem, we are thinking of an algorithm, which

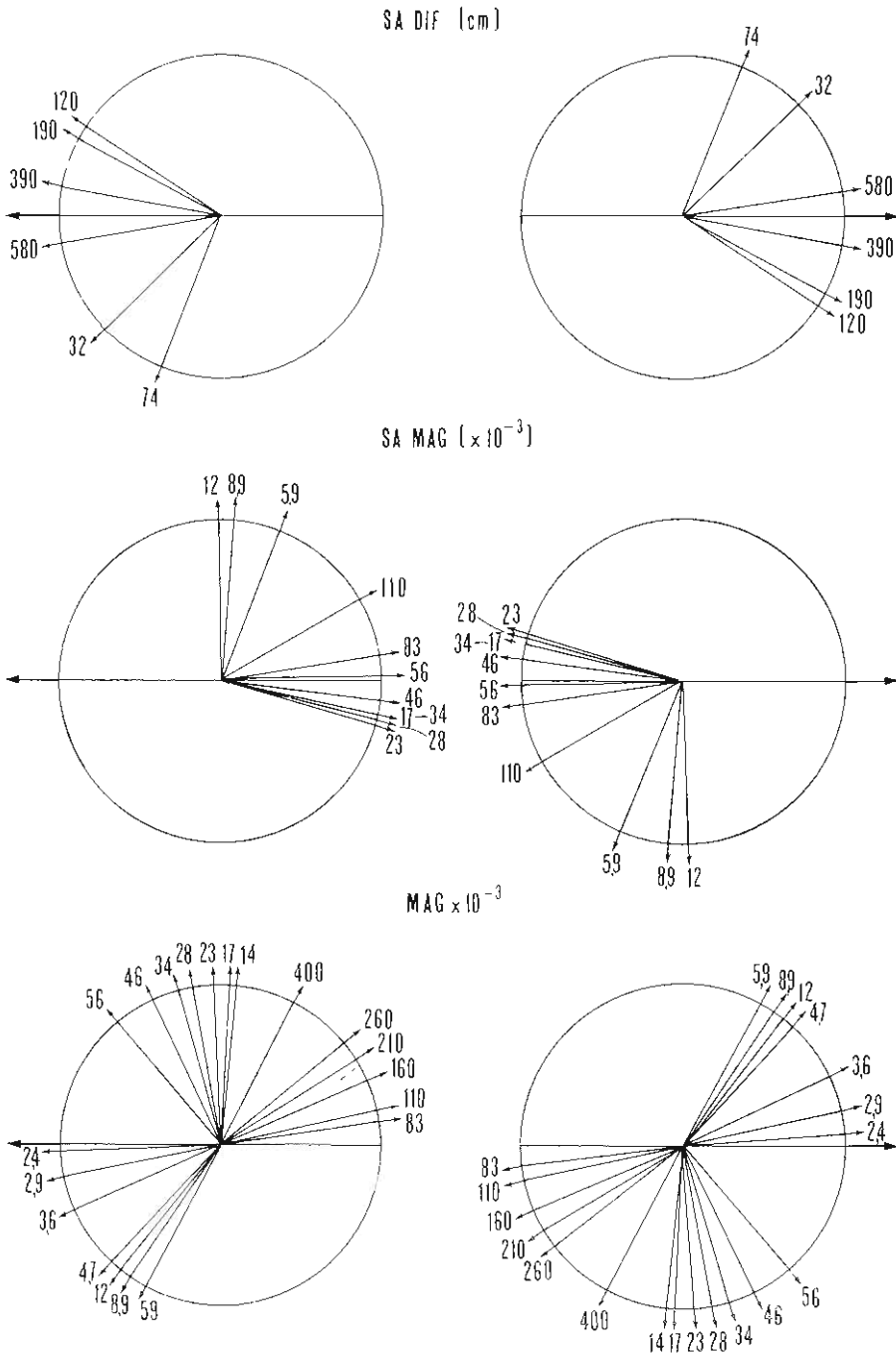


Fig. 3

would be translated into a program working with an on-line computer, which would make, roughly speaking, indexing of diffraction spots and also would give to the operator the tilt angle needed to reach a desired spot. The block diagram of such a logic is given in Fig. 4.

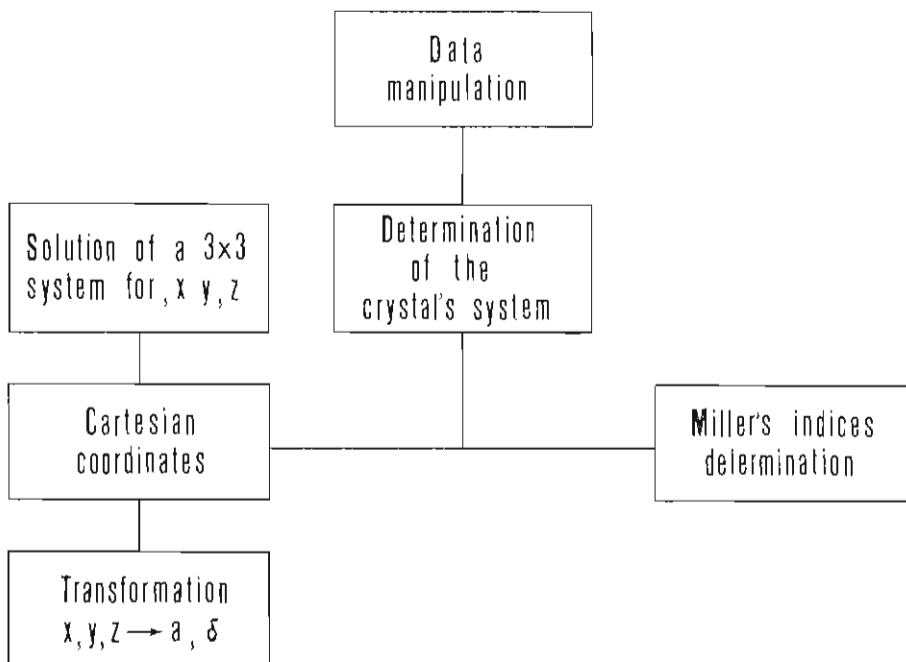


Fig. 4

#### REFERENCES

1. Karakostas Th., Nouet G., Bleris G. L., Hagege S. and Delavignette P., Phys. stat. sol. (a), **50**, 703 (1978).

## ΠΕΡΙΛΗΨΗ

### ΤΕΜ ΚΑΙ ΥΠΟΛΟΓΙΣΤΙΚΕΣ ΜΕΘΟΔΟΙ ΣΕ ΜΕΛΕΤΕΣ ΚΡΥΣΤΑΛΛΩΝ

#### Ι. ΒΑΘΜΟΝΟΜΗΣΗ ΤΟΥ ΗΛΕΚΤΡΟΝΙΚΟΥ ΜΙΚΡΟΣΚΟΠΙΟΥ

Υπό

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Η εργασία αυτή αποτελεί την πρώτη μιᾶς σειράς εργασιῶν πού ἔχουν ὡς σκοπὸ νὰ συνδυάσουν παρατηρήσεις στὸ ἠλεκτρονικὸ μικροσκόπιο μὲ ταυτόχρονους ὑπολογισμοὺς πού θὰ γίνονται μὲ ἠλεκτρονικὸ ὑπολογιστὴ. Δίνει, γιὰ τὸ ἠλεκτρονικὸ μικροσκόπιο JEOL 120 CX τοῦ Φυσικοῦ τμήματος τοῦ Α.Π.Θ., τοὺς πίνακες καὶ τὰ διαγράμματα πού εἶναι ἀπαραίτητα γιὰ νὰ καθοριστεῖ ἡ θέση τοῦ συστήματος συντεταγμένων τοῦ κρυστάλλου (δεῖκτες Miller) μέσα στὸ σύστημα συντεταγμένων τοῦ ὄργανου. Ἐτσι ὁ χειριστὴς τοῦ μικροσκοπίου μπορεῖ νὰ κάνει ὀρισμένους σχετικὰ ἀκριβεῖς χειρισμοὺς τὴν ὥρα τῆς παρατήρησης ὅπως ἐπίσης ἀπόλυτα ἀκριβεῖς ὑπολογισμοὺς μετὰ τὸ τύπωμα τῆς φωτογραφίας. Τὰ δεδομένα αὐτὰ προβλέπεται νὰ συνδυαστοῦν μὲ ἕναν ὑπολογιστὴ on-line.